



REGISTRATION

www.izm.fraunhofer.de/en/news events/events/ws 8 You will find hotels near the venue on the registration website.

PARTICIPATION FEE

780 € per person The fees are VAT exempt according to § 4 No. 22 UStG.

10% discount for members of one of the Innovation Networks for Optical Technologies (Innovationsnetze Optische Technologien, OptecNet Deutschland), or EPIC (European Photonics Industry Consortium)

VENUE

Fraunhofer Institute for Reliability and Microintegration IZM Gustav-Meyer-Allee 25 | Bld. 17.3, Raum 60a+b 13355 Berlin

WHO SHOULD ATTEND

The workshop addresses scientists and engineers involved in photonic packaging: Process technology, materials and equipment, as well as decision makers.

FRAUNHOFER INSTITUTE FOR **RELIABILITY AND MICROINTEGRATION IZM**

PHOTONIC PACKAGING SUB-MICRON ASSEMBLY

WORKSHOP | JUNE 12-13, 2018



WORKSHOP OVERVIEW

Photonic integration in data communication is driven today both by the increasing demand for bandwidth and higher channel density within the systems. Furthermore miniaturization in lightening and projection techniques, and a wide variety of optical sensors require new photonic assembly concepts to reduce costs and guarantee reliability. Photonic integrated circuits (PIC) and MOEMS based devices need 3D-integration, and challenges in terms of optical fibre attachment have to be solved. Photonic packaging is crucial and includes single packages, modules or subsystems comprising at least one optoelectronic device or micro-optical element and optical interconnects.

High precision alignment is a key, yet the lack of standards for photonic interconnects hinders low cost generic solutions. We see that there are many challenges to be taken by OEM manufacturers, suppliers and service assemblers to face the specific challenges regarding very tight tolerances. Sub-micron accuracy has to be achieved and maintained during operation for many photonic applications.

Thus the Photonics Packaging workshop 2018 at Fraunhofer IZM focuses on sub-micron assembly technologies for optoelectronic and photonic integration on board, package and device level.

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In cooperation with





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Automated active alignment of an out-of-plane coupling ele EOCB (electrical-optical cicuit board)

PROGRAM JUNE 12TH

13.00 Welcome

SESSION 1: ADVANCED PHOTONIC NEEDS FOR HIGH PRECISION

- **13.20** Photonic integrated soliton frequency combs Tobias J. Kippenberg, EPFL, Lausanne, CH
- 13.40 Miniaturized optical quantum technologies on ground and in space

Markus Krutzik, Institut für Physik, HU Berlin, GER

14.00 High precision mounting - Enabling new micro laser sources for biophotonics

Kathrin Paschke, Ferdinand Braun Institut für Höchstfrequenztechnik, Berlin, GER

- 14.20 Coffee Break SESSION 2: PIC ASSEMBLING AND PACKAGING ON WAFER LEVEL
- 14.50 Industrial requirements for high precision optoelectronic assemblies

Gunter Vollrath, Aifotec AG, Meiningen, GER

15.10 Wafer level processing and packaging of optical modules utilizing nanoimprint lithography and wafer bonding

Martin Eibelhuber, EV Group, St. Florian am Inn, AT

15.30 Precision flip chip bonding optoelectronic components

Hermann Oppermann, Fraunhofer IZM, Berlin GER

15.50 Optical spot size conversion in photonic BiCMOS: Fabrication and characterization

> Lars Zimmermann, IHP – Leibniz-Institut für innovative Mikroelektronik, Frankfurt/Oder, GER

- 16.10 Coffee Break SESSION 3: MODULE INTEGRATION AND PACKAGING
- 16.40 Photonic wirebonding and 3D nano-printing in optical packaging - From research to manufacturing Christian Koos, Vanguard Photonics GmbH and Karlsruher Institut für Technologie, Karlsruhe, GER
- 17.00 Assembly of silicon photonics transceiver modules for optical data center interconnects Christoph Theiss, Sicoya GmbH, Berlin, GER
- **17.20** Chip I/O disaggregation. Co-package of a 2D optical interconnect with a switch ASIC Kobi Hasharoni, Dust Photonics LTD, Modiin, ISR
- 17.50 Advanced photonics packaging and integration of silicon photonic devices at CNIT/InPhoTec Giovan Battista Preve/Davide Rotta, CNIT/InPhoTec Foundation, Pisa, ITA
- 18.00 Get-together with special lab-tour: Start-a-Factory @ Fraunhofer IZM

PROGRAM JUNE 13TH

Automated active lens alignment for laser modules

- 9.00 Welcome SESSION 4: PRECISION STRUCTURING AND PASSIVE ALIGNMENT
- 9.20 Optical fiber assemblies for high-precision fiber to chip coupling Andreas Matiss, Corning Optical Communications

GmbH&Co. KG, Berlin, GER

- 9.40 Sub-micron passive alignment of photonics for production: What about process and machine capability? Rudolf Kaiser, Amicra Microtechnologies GmbH, Regensburg, GER
- 10.00 High precision optical 3D-microassembly for volume production based on Si-micromechanics Jörg-R. Kropp, InBeCon GmbH, Berlin, GER
- 10.20 Hybrid InP-TriPleX packaging in multi project wafer access

Arnde Leinse, LioniX International BV, Enschede, NL

- 10.40 Coffee Break SESSION 5: AUTOMATION AND PRECISE ACTIVE ALIGNMENT
- 11.10 High-volume submicron attachment using active alignment

Torsten Vahrenkamp, ficonTEC Service GmbH, Achim, GER

11.30 Sub-micron passive alignment and bonding with automatic offset correction based on indirect visual feedback or external measurements Precise micro optical bench assembly and fiber coupling

Martin Rogge, Finetech GmbH&Co KG, Berlin, GER

11.50 Interferometric feedback for the SmarPod 6D-Parallel kinematics: Tackling mechanical tolerances with the PicoScale

Kolja Kolata, SmarAct GmbH, Oldenburg, GER

12.10 Recent advances in high-throughput, ultraprecision photonic alignment for industrial test and packaging

Scott Jordan, Physik Instrumente, Sausolito, USA

- 12.30 Lunch Break SESSION 6: OPTICAL INTERCONNECTS AND HYBRID COMPONENT INTEGRATION
- 13.30 Additive and subtractive 3D printing of transparent materials with sub-micron precision Martin Hermans, LightFab GmbH, Aachen, GER
- 13.50 Integration of technologies for the development of photonic-based lab-on-a-chip devices Jaime Garcia-Ruperez, Polytechnic University of Valencia, Valencia, ES
- 14.10 Addressing cost and reliability targets for application specific packages

Jörg Muchametow, eagleyard photonics GmbH, Berlin, GER

14.30 Thin glass based optical sub-assemblies of electrooptical components

Gunnar Böttger, Fraunhofer IZM, Berlin, GER